

<b>PATENT ASSIGNMENT COVER SHEET</b>
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Electronic Version v1.1  
 Stylesheet Version v1.2

EPAS ID: PAT7841797

<b>SUBMISSION TYPE:</b>	NEW ASSIGNMENT
<b>NATURE OF CONVEYANCE:</b>	PATENT PURCHASE AGREEMENT
<b>CONVEYING PARTY DATA</b>	
<b>Name</b>	<b>Execution Date</b>
GLOBALFOUNDRIES US, INC.	03/03/2023
<b>RECEIVING PARTY DATA</b>	
<b>Name:</b>	PORTAGE ACQUISITIONS LLC
<b>Street Address:</b>	548 MARKET STREET, #36676
<b>City:</b>	SAN FRANCISCO
<b>State/Country:</b>	CALIFORNIA
<b>Postal Code:</b>	94104
<b>PROPERTY NUMBERS Total: 2</b>	
<b>Property Type</b>	<b>Number</b>
<b>Patent Number:</b>	9392679
<b>Patent Number:</b>	9541839
<b>CORRESPONDENCE DATA</b>	
<b>Fax Number:</b>	(650)938-5200
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
<b>Phone:</b>	6503357607
<b>Email:</b>	dchevalier@fenwick.com, cdiez@fenwick.com
<b>Correspondent Name:</b>	RAJIV P. PATEL
<b>Address Line 1:</b>	801 CALIFORNIA STREET
<b>Address Line 4:</b>	MOUNTAIN VIEW, CALIFORNIA 94041
<b>ATTORNEY DOCKET NUMBER:</b>	37967-01000
<b>NAME OF SUBMITTER:</b>	RAJIV P. PATEL
<b>SIGNATURE:</b>	/RAJIV P. PATEL/
<b>DATE SIGNED:</b>	03/13/2023
<b>Total Attachments: 2</b>	
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**Exhibit B-2**  
**Assignment of Patent Rights (U.S. Patents 9,392,679 and 9,541,839)**

GlobalFoundries US, Inc., a Delaware corporation, with offices at 2600 Great America Way, Santa Clara, CA 95054 (“ASSIGNOR”), and Portage Acquisitions LLC, a Delaware limited liability company, with offices at 548 Market Street, #36676, San Francisco CA 94104 (“ASSIGNEE”) have entered into a certain Patent Purchase Agreement, pursuant to which ASSIGNOR has sold, assigned, and transferred and does hereby sell, assign, and transfer to ASSIGNEE, for itself and its successors, transferees, and assignees, the following patents, including (a) any right of priority; (b) any divisional, continuation, substitute, renewal, reissue, and other related applications thereto which have been or may be filed in the United States or elsewhere in the world; (c) any patents which may be granted on the applications set forth in (a) and (b) above; and (d) the right to sue in its own name and to recover for past infringement of any or all of any applications or patents issuing therefrom:

<b>Country:</b>	<b>Issued Patent No.:</b>	<b>Title:</b>	<b>Issue Date:</b>
U.S.	9,392,679	Method, apparatus and system for using free-electron laser compatible EUV beam for semiconductor wafer processing	7/12/2016
U.S.	9,541,839	Method and device for splitting a high-power light beam to provide simultaneous sub-beams to photolithography scanners	January 10, 2017

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**Assignment of Patent Rights (U.S. Patents 9,392,679 and 9,541,839)**  
*(Signature Page)*

Duly Authorized Representative of ASSIGNOR

*Adam Noah*

Signature

Adam Noah

Printed Name

VP and Chief IP Counsel

Title

Date of Signature

3/3/2023

Duly Authorized Representative of ASSIGNEE

*James Proud*

Signature

James Proud

Printed Name

CEO

Title

Date of Signature

3/3/2023